



IMPACT advanced characterization chambers details

XPS (Thermo Fisher)

- √ pAR-XPS (parallel angle resolved XPS)
- ✓ Angles from 20° to 80° without sample tilt
- ✓ Spot size 20 to 400µm
- ✓ Ion beam Ar etching for abrasion

Ellipsometry (Horiba Jobin Yvon)

- ✓ IR to V-UV : 12 µm (0,1 eV) to 145 nm (8,55 eV)
- ✓ Azimutal rotation
- √ Sample heating (up to 450°C)



Small samples to 300 mm loading capability

Photolum / Raman (Horiba Jobin Yvon)

- ✓ Based on Labram HR (best in class Raman system)
- ✓ IR to UV (3 lasers : 355nm / 532nm / 1064 nm)
- ✓ Confocal measurements (depth resolution)
- ✓ Spatial resolution < 3µm</p>

Cleavage

- ✓ Glove box with vacuum capability or controlled atmosphere
- ✓ Manual Cleaving under controlled atmosphere
- ✓ Possibility of sample's transfer to PFNC instruments by vacuum carrier

